

PATENT  
1739-0175P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: KESSLER, Berthold et al. Conf.:

Appl. No.: NEW Group:

Filed: August 5, 2003 Examiner:

For: METHOD AND SENSOR DEVICE FOR MONITORING A LASER MACHINING OPERATION TO BE PERFORMED ON A WORK PIECE AS WELL AS A LASER MACHINING HEAD WITH A SENSOR DEVICE OF THIS KIND

PRELIMINARY AMENDMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

August 5, 2003

Sir:

The following preliminary amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes:

Amendments to the Specification; and

Remarks.